Application Number:	100	10624537					
Filing Date:	23-	23-Jul-2003					
Title of Invention:		MANUFACTURING METHOD FOR MONOLITHIC PIEZOELECTRIC PART, AND MONOLITHIC PIEZOELECTRIC PART					
First Named Inventor/Applicant Name:	Kat	Katsuhiro Horikawa					
Filer:	Ed	Edward A. Meilman/Inga Hildreth					
Attorney Docket Number:	M1	M1071.1855/P1855					
Filed as Large Entity							
Utility under 35 USC 111(a) Filing Fees	;						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:					I.		
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							

Publ. Fee- early, voluntary, or normal

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:	·			
Miscellaneous:				
Printed copy of patent - no color	8001	10	3	30
	Tot	Total in USD (\$)		